AF/2815



PATENT 3430-0131P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Kwang-Jo HWANG

Conf.:

Appl. No.:

09/648,111

Group:

2815

Filed:

August 25, 2000

Examiner: BROCK II, P.

For:

METHOD OF PATTERNING A METAL LAYER IN A

SEMICONDUCTOR DEVICE

LARGE ENTITY TRANSMITTAL FORM

Assistant Commissioner for Patents Washington, DC 20231	January 16, 2002
Sir:	JAN 2 2800
Transmitted herewith is an amendment in the application.	above-identified ROOM
The enclosed document is being transmitted vi of Mailing provisions of 37 C.F.R. § 1.8.	
The enclosed document is being transmitted v	<i>r</i> ia facsimile.
The fee has been calculated as shown below:	

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	29	_	29	=		\$18	\$0.00
INDEPENDENT	3	-	3	=		\$84	\$0.00
FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM				\$280	\$0.00		
						TOTAL	\$0.00

Appl. No. 09/648,111

	Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.	
\boxtimes	No fee is required.	
	Check(s) in the amount of \$0.00 is(are) enclosed.	
	Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.	Þ

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

Ву___

Joseph A. Kolasch, #22,4

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Falls Church, VA 22040-0747

(703) 205-8000

ATTACHMENT

3430-0131P

(Rev. 09/27/01)



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

HWANG, Kwang-Jo

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EXAMINER: Brock II, P.

FOR:

METHOD OF PATTERNING A METAL LAYER IN A

SEMICONDUCTOR DEVICE

AMENDMENT

Box A.F.

Assistant Commissioner for Patents

Washington, D.C. 20231

Date: January 16, 2002

Dear Sir:

In response to the Final Office Action dated October 16, 2001, the following amendments and remarks are respectfully submitted under 37 C.F.R. §1.116 in connection with the above-identified application.

IN THE CLAIMS:

Please cancel claim 12 without prejudice or disclaimer to the subject matter contained therein.

Please amend the claims as follows:

13. (Amended) The method of claim 30, wherein the first plasma is a reactive gas.

